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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of: **Hiroyuki OHTA**

Group Art Unit: **2812**

Serial No.: **10/668,211**

Examiner: **Walter L. Lindsay, Jr.**

Filed: **September 24, 2003**

Confirmation No.: **1590**

For: **REDUCTION IN SOURCE-DRAIN RESISTANCE OF
SEMICONDUCTOR DEVICE**

Attorney Docket Number: **031106**

Customer Number: **38834**

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §1.97(b)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: January 28, 2005

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the references listed on the attached PTO-1449. This paper is being filed within the time periods set forth in 37 C.F.R. §1.97(b).

Each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counter part foreign application not more than three months prior to the filing of this statement.

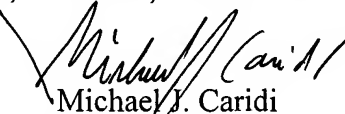
A copy of each non-U.S. document is enclosed herewith.

Information Disclosure Statement
Application No.: 10/668,211
Attorney Docket No. 031106

If there are any fees due in connection with the filing of this paper, please charge Deposit
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Respectfully submitted,

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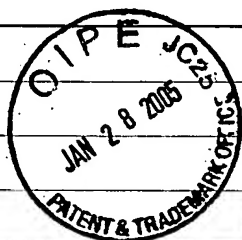
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Enclosure: PTO Form 1449 and Reference(s)

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U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)



FOREIGN PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Country	Translation (Yes or No)
	07-066406	3/10/1995	JAPAN	Abstract
	05-218410	8/27/1993	JAPAN	Abstract
	2002-151683	5/24/2002	JAPAN	Abstract
	2001-274385	10/5/2001	JAPAN	Abstract
	05-029341	2/5/1993	JAPAN	Abstract

OTHER DOCUMENTS

		Japanese Office Action (With Translation) – Mailing date 11/9/2004 – Patent Application No. 2002-285372
Examiner		Date Considered